

**Conductance and gating effects at sputtered oxide interfaces** Yin, C.

# Citation

Yin, C. (2019, July 3). *Conductance and gating effects at sputtered oxide interfaces. Casimir PhD Series*. Retrieved from https://hdl.handle.net/1887/74527

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Author: Yin, C. Title: Conductance and gating effects at sputtered oxide interfaces Issue Date: 2019-07-03

# A

# Self-consistent

**Schrödinger-Poisson calculation** 

# A.1. Introduction

The self-consistent Schrödinger-Poisson (S-P) model was first used by F. Stern to study energy levels, populations, and charge distributions in *n*-type inversion layers on *p*-type Si in 1972 [133]. It has also been used by several groups to provide valuable insights into experimental results in LaAlO<sub>3</sub>/SrTiO<sub>3</sub> heterostructures [89, 90, 128, 132, 135].

In the S-P model, quantum effects are taken into account in the effective mass approximation, and the envelope wave function is assumed to vanish at the surface [133]. Compared to Si inversion layers, calculations for the LaAlO<sub>3</sub>/SrTiO<sub>3</sub> interface are more complicated, which is due to the anisotropic effective mass of the Ti 3*d* orbitals and the field-dependent permittivity of the SrTiO<sub>3</sub> substrate [62, 91].

#### A.1.1. Anisotropic effective mass of Ti 3d orbitals

The LaAlO<sub>3</sub> film is grown on a SrTiO<sub>3</sub> (001) substrate, and the S-P calculation is performed along the growth direction, *i.e.* the *z* direction. The effective masses of the  $d_{xy}$ and  $d_{xz,yz}$  subbands are anisotropic. We take the masses of the various bands as

$$m_{xy}^{x,y} = m_l, \quad m_{xy}^z = m_h; m_{xz}^{x,z} = m_l, \quad m_{xz}^y = m_h; m_{yz}^{y,z} = m_l, \quad m_{yz}^y = m_h,$$
(A.1)

where  $m_l = 0.7m_e$  and  $m_h = 14m_e$  [89, 124, 134], with  $m_e$  being the mass of a free electron.

# A.1.2. Permittivity of SrTiO<sub>3</sub>



Figure A.1: (a) Temperature dependence of the permittivity ( $\epsilon_r$ ) of SrTiO<sub>3</sub> without gate voltage applied. Image adapted from Ref. [62]. (b) Electric-field dependence of  $\epsilon_r$  at 4.2 K from two empirical expressions [123, 132].

SrTiO<sub>3</sub> single crystal has a temperature-dependent permittivity ( $\epsilon_r$ ) as shown in Fig. A.1(a), which reaches >20000 at low temperature. However,  $\epsilon_r$  decreases when an electric

field (*E*) is applied to the material. So far, the field dependence of  $\epsilon_r$  is still described by empirical expressions. Here, we discuss two widely used expressions. The first one was reported by Neville *et al.* [123]:

$$\epsilon_{\rm r}(E) = \frac{1}{A(T) + B(T)|E|},\tag{A.2}$$

where A(T) is the inverse zero-field permittivity as a function of temperature, and B(T) is the field-dependent part as a function of temperature. At 4.2 K,  $A = 4.097 \times 10^{-5}$  and  $B = 4.907 \times 10^{-10}$  m/V for the (001) direction. The second one was reported by Gariglio *et al.* [132]:

$$\epsilon_{\rm r}(E) = 1 + \frac{B}{[1 + (E/E_0)^2]^{1/3}},$$
 (A.3)

where B = 25462, and  $E_0 = 82213$  V/m. It can be seen from Fig. A.1(b) that the two curves overlap well in low fields but differ a lot in high fields. In LaAlO<sub>3</sub>/SrTiO<sub>3</sub> heterostructures, the typical electric field at the interface is on the order of  $10^7$  V/m. Therefore, the two expressions can lead to very different results. We use Eq. (A.3) in our calculation.

# A.2. Self-consistent Schrödinger-Poisson calculation

The S-P model involves the Schrödinger equation

$$\left(-\frac{\hbar^2}{2m_{\alpha}^z}\frac{d^2}{dz^2} + eV(z)\right)\psi_{n\alpha}(z) = \epsilon_{n\alpha}\psi_{n\alpha}(z), \quad n = 1, 2, 3, \cdots,$$
(A.4)

and the Poisson equation

$$-\frac{d}{dz}\left(\epsilon_{0}\epsilon_{\rm r}(E(z))\frac{d}{dz}V(z)\right) = \rho_{\rm 3D}(z),\tag{A.5}$$

where  $\alpha = xy$ , xz, yz labels the Ti  $t_{2g}$  orbitals  $(d_{xy}, d_{xz}, d_{yz})$ , V(z) is the confining potential,  $\psi_{n\alpha}(z)$  and  $\epsilon_{n\alpha}$  are normalized wave function and eigen value of the *n*th subband of the  $\alpha$  orbital, respectively,  $\epsilon_0$  is the vacuum permittivity, and  $\rho_{3D}(z)$  is the three-dimensional (3D) charge distribution.

At the LaAlO<sub>3</sub>/SrTiO<sub>3</sub> interface, electrostatic confinement is described by the confining potential V(z), which can be calculated by the Poisson equation. For a given charge distribution and electrostatic boundary conditions, V(z) is uniquely defined. On the other hand, for a given V(z), the distribution of mobile electrons is determined by the population of bound states in V(z), which can be calculated by the Schrödinger equation. Therefore, the coupling between these two equations could enable a self-consistent calculation of V(z). A schematic of the self-consistent S-P calculation is shown in Fig. A.2. Α



Figure A.2: Schematic of the Schrödinger-Poisson calculation, which contains two self-consistent loops. The first loop (dotted teal box) is for calculating the electric field E(z) and the second loop (dotted purple box) for the electric potential V(z).

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### A.2.1. Input parameters

Input parameters of the S-P calculation include the initial mobile electron density  $n_0^m$ , the initial trapped electron density  $n_0^{tr}$ , the gate-induced mobile electron density  $n_G^m(V_G)$ , the gate-induced trapped electron density  $n_G^{tr}(V_G)$ , a trial wave function  $\psi_0(z)$ , and a trial electric field  $E_0(z)$ . Now we discuss them one by one.

### Initial mobile and trapped electron density

Initial mobile electron density  $n_0^{\rm m}$  is the sheet carrier density of the virgin state, which is obtained from magnetotransport measurement. In our sample,  $n_0^{\rm m} = 1.41 \times 10^{13} \, {\rm cm}^{-2}$ . Initial trapped electron density  $n_0^{\rm tr}$  can only be obtained from trial and error until the calculated results cover the experimental results. In our case,  $n_0^{\rm tr} = 6.4 \times 10^{13} \, {\rm cm}^{-2}$ . We take  $z \ge 0$  to be SrTiO<sub>3</sub> and z < 0 to be LaAlO<sub>3</sub>. The positive charge density is  $n_0^{\rm m} + n_0^{\rm tr}$  on the LaAlO<sub>3</sub> side as the boundary condition, which keeps an overall charge neutrality.

#### Gate-induced mobile and trapped electron density

In back-gating experiment, the total amount of electrons  $n_{\rm G}^{\rm tot}(V_{\rm G})$  induced by the gate voltage ( $V_{\rm G}$ ) can be calculated using a parallel plate capacitor model [130, 131]:

$$n_{\rm G}^{\rm tot}(V_{\rm G}) = \int_{V_1}^{V_2} \frac{\epsilon_0}{ed_{\rm STO}} \epsilon_{\rm r}(V_{\rm G}) dV_{\rm G},\tag{A.6}$$

where  $d_{\text{STO}} = 0.5 \text{ mm}$  is the thickness of the  $\text{SrTiO}_3$  substrate, and  $E = V_G/d_{\text{STO}}$ . It should be noted that the electric field *E* here is considered to be position independent. The reason is that *E* only changes significantly at the interface within about 20 nm and is constant in the  $\text{SrTiO}_3$  bulk. As discussed in Chapter 4, the gate-induced trapped electron density  $n_G^{\text{tr}}(V_G)$  can only be obtained from experimental results. In our sample,

$$n_{\rm G}^{\rm tr}(V_{\rm G}) = N(1 - e^{-\frac{V_{\rm G}}{400}}),$$
 (A.7)

where  $N = 6.2 \times 10^{13} \text{ cm}^{-2}$ . Therefore, the gate-induced mobile electron density

$$n_{\rm G}^{\rm m}(V_{\rm G}) = n_{\rm G}^{\rm tot}(V_{\rm G}) - n_{\rm G}^{\rm tr}(V_{\rm G}).$$
 (A.8)

## Trial wave function and trial electric field

A trial wave function ( $\psi_0(z)$ ) gives a first guess of the mobile charge distribution. We use the Fang-Howard variational wave function, which gives a good approximation for the ground state in the *z* direction [131]

$$\psi_0(z) = \sqrt{\frac{b^3}{2}} z e^{-\frac{bz}{2}},\tag{A.9}$$

where b is the variational parameter

$$b = \left(\frac{33\pi}{2} \left(n_0^{\rm m} + n_{\rm G}^{\rm m}(V_{\rm G})\right) a_{\rm B}^2\right)^{\frac{1}{3}} \frac{1}{a_{\rm B}},\tag{A.10}$$

where  $a_{\rm B}$  is the Bohr radius

$$a_{\rm B} = \frac{4\pi\epsilon_{\rm r}\epsilon_0\hbar^2}{m^*e^2}.\tag{A.11}$$

It should be noted that the actual input values for Eq. (A.11) do not affect the final results. We take  $\epsilon_r = 1$  and  $m^* = m_e$ .

A trial electric field ( $E_0(z)$ ) can be any reasonable value and we take  $E_0(z) = 1000 \text{ V/m}$ .

## A.2.2. Self-consistent calculation

First, we calculate the 3D charge distribution  $\rho_{3D}(z)$ , which is the sum of the distribution of mobile and trapped electrons,

$$\rho_{3\rm D}(z) = \rho_{3\rm D}^{\rm m}(z) + \rho_{3\rm D}^{\rm tr}(z). \tag{A.12}$$

The mobile charge distribution is given by

$$\rho_{3\mathrm{D}}^{\mathrm{m}}(z) = -e \left( n_0^{\mathrm{m}} + n_{\mathrm{G}}^{\mathrm{m}}(V_{\mathrm{G}}) \right) \left| \psi_0(z) \right|^2.$$
(A.13)

The trapped charge distribution should also be obtained from trial and error. In our sample,

$$\rho_{3\mathrm{D}}^{\mathrm{tr}}(z) = \begin{cases} 0 & \text{for } z < 0\\ -e \frac{n_0^{\mathrm{tr}} + n_G^{\mathrm{tr}}(V_G)}{\lambda} e^{-\frac{z}{\lambda}} & \text{for } z \ge 0 \end{cases}$$
(A.14)

where  $\lambda = 50$  nm.

Integration of Eq. (A.5) along the z direction gives

$$-\epsilon_0 \epsilon_{\rm r}(E(z)) \frac{d}{dz} V(z) = -\epsilon_0 \epsilon_{\rm r}(E(z)) E(z) = \int_0^L \rho_{\rm 3D}(z) dz, \tag{A.15}$$

where the integration range is from 0 to L = 100 nm, which is divided into 2000 equal sections.

Now we enter the first self-consistent loop for calculating E(z) as shown in Fig. A.2. The convergence is checked by

$$\eta = \frac{1}{L} \int_0^L \left( \frac{E_i(z) - E_{i-1}(z)}{E_i(z)} \right)^2 dz.$$
(A.16)

If  $\eta$  is large than the error tolerance  $\epsilon_p$  (set to  $10^{-5}$ ), a new electric field ( $E'_i(z)$ ) is calculated by the over relaxation method in order to get a faster convergence

$$E'_{i}(z) = \zeta E_{i-1}(z) + (1-\zeta)E_{i}(z), \tag{A.17}$$

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where  $\zeta = 0.3$ . If  $\eta$  is smaller than  $\epsilon_p$ , the calculation is converged. Integration of  $E_i(z)$  along the *z* direction gives the electric potential  $V_{i-1}(z)$ .

Next,  $V_{j-1}(z)$  is injected into Eq. (A.4). The outcome of solving the Schrödinger equation is the eigen values ( $\epsilon_{n\alpha}$ ) and the normalized wave functions ( $\psi_{n\alpha}(z)$ ) of the subbands of different  $t_{2g}$  orbitals. We can calculate the mobile charge distribution again with  $\epsilon_{n\alpha}$  and  $\psi_{n\alpha}(z)$ :

$$\rho_{\rm 3D}^{\rm m}(z) = -e \sum_{n,\alpha} \Theta(E_{\rm F} - \epsilon_{n\alpha}) \frac{\sqrt{m_{\alpha}^{x} m_{\alpha}^{y}}}{\pi \hbar^{2}} (E_{\rm F} - \epsilon_{n\alpha}) \left| \psi_{n\alpha}(z) \right|^{2}, \tag{A.18}$$

where  $\Theta$  is the Heaviside step function and  $E_F$  is the Fermi energy.  $E_F$  can be obtained by numerically solving

$$n_0^{\rm m} + n_{\rm G}^{\rm m}(V_{\rm G}) = \sum_{n,\alpha} \Theta(E_{\rm F} - \epsilon_{n\alpha}) \frac{\sqrt{m_{\alpha}^{x} m_{\alpha}^{y}}}{\pi \hbar^2} (E_{\rm F} - \epsilon_{n\alpha}). \tag{A.19}$$

A new  $\rho_{3D}(z)$  is obtained by summing up Eq. (A.14) and Eq. (A.18).

Now we enter the larger self-consistent loop for calculating V(z) as shown in Fig. A.2. By treating the new electric potential  $V_j(z)$  and  $V_{j-1}(z)$  with the same manner as shown in Eq. (A.16) and Eq. (A.17), a converged electric potential V(z) can be obtained.

The subband dispersion can be calculated by

$$E_{n\alpha} = \frac{\hbar^2 k_x^2}{2m_{\alpha}^x} + \frac{\hbar^2 k_y^2}{2m_{\alpha}^y} + \epsilon_{n\alpha}, \qquad (A.20)$$

where  $k_x$  and  $k_y$  are the wavevector in the *x* and *y* directions, respectively.

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